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Docket No.: 4539-0115PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hiroshi NAKANISHI et al.

Application No.: 10/582,172

Confirmation No.: 8941

Filed: June 8, 2006

Art Unit: 2883

For: METHOD OF PRODUCING MICRO-LENS-
CARRYING DISPLAY PANEL AND
DISPLAY UNIT AND EXPOSURE SYSTEM

Examiner: Kaveh C. Kianni

REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Restriction Requirement dated October 26, 2007, the following remarks are respectfully submitted in connection with the above-identified application.